

<b>Notice of References Cited</b>	Application/Control No. 10/829,392	Applicant(s)/Patent Under Reexamination WAGNER ET AL.	
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*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Jurik et al.; Laser – Assisted Particle Removal; 11/24/2003
	V	Rizvi et al.; Direct manufacture of Miniature Bio-Particle Electro-manipulator Devices using Excimer Laser Mask Projection Techniques; 1998; Exitech Limited, Long Hanborough, Oxford OX8 8Lh, UK□□
	W	Scott; Overview of Spin Coating; 12/01/2000; www.polymerprocessing.com□□
	X	Knowles et al.; Micromachining of Metals, Ceramics, Silicon and Polymers using Nanosecond Lasers

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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	W	Bostanjoglo et al.; Design of variable reflective mirrors and unstable resonators for ND: YAG lasers with high average power; 1994; IOP Publishing
	X	Chang et al.; Micro-optic fabrication using laser ablation process; Proc. SPIE Vol. 4760, p. 1014-1023, High-Power Laser Ablation IV, Claude R. Phipps; 09/2002

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	W	msn encarta; thesaurus; vacate; 2006
	X	semiconductor glossary; 6/6/2003; definition crystal; www.semiglossary.com

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